



Docket No.: SON-2563  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Koichiro Shoji

Application No.: 10/501,155

Confirmation No.: 5207

Filed: July 13, 2004

Art Unit: 1792

For: SURFACE TREATMENT METHOD,  
SEMICONDUCTOR DEVICE, METHOD OF  
FABRICATION SEMICONDUCTOR DEVICE  
AND TREATMENT APPARATUS

Examiner: N. R. Blan

**AMENDMENT FOR FILING WITH  
A REQUEST FOR CONTINUED EXAMINATION (RCE) UNDER 37 C.F.R. §1.114**

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated June 11, 2008, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.